IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent application of : Mail Stop Amendment

Sung-Sok Choi : Group Art Unit 1763

Serial No. 10/813,439 : Examiner Zervigon, Rudy

Filed March 31, 2004

Title: Apparatus and System for, and Method of Supplying Process Gas in

SEMICONDUCTOR DEVICE MANUFACTURING EQUIPMENT

REQUEST FOR RECONSIDERATION

U.S. Patent and Trademark Office

Customer Window, Mail Stop Amendment
Randolph Building
401 Dulany Street
Alexandria, VA 22314

Sir:

This is in response to the Office Action dated February 7, 2007.

Remarks/Arguments begin on page 2 of this paper.